

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of:

Applicant(s): Kai Numssen et al.
Serial No: 10/684,811
Filing Date: October 14, 2003
Title: METHOD FOR MANUFACTURE OF A HIGH TEMPERATURE
SUPERCONDUCTING LAYER

Examiner: Talbot, Brian K
Art Unit: 1762
Docket No. BARDP0124US

REPLY TO OFFICE ACTION DATED OCTOBER 10, 2007

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Favorable reconsideration of the above-referenced application is respectfully requested in view of the following part(s) of this reply:

Listing of the Claims
Remarks

Enclosures: ☐ Credit Card Payment
☐ Petition for Extension of Time
☐ Information Disclosure Statement

In the event any fee or additional fee is due in connection with the filing of this paper, the Commissioner is authorized to charge those fees to our Deposit Account No. 18-0988 (under the above Docket Number). In the event an extension of time is needed to make the filing of this paper timely and no separate petition is attached, please consider this a petition for the requisite extension and charge the fee to our Deposit Account No. 18-0988 (under the above Docket Number).